



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaru MITSUI

Group Art Unit: 1795

Application No.: 10/523,470

Examiner: R. MCDONALD

Filed: March 10, 2005

Docket No.: 122672

For: METHOD FOR MANUFACTURING MASK BLANK, METHOD FOR  
MANUFACTURING TRANSFER MASK, SPUTTERING TARGET FOR  
MANUFACTURING MASK BLANK

**AMENDMENT FILED WITH RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 22, 2009 Office Action, the shortened statutory period for reply  
being extended by the attached Petition for Extension of Time, and upon entry of the attached  
Request for Continued Examination, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**